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PIEZOELECTRICALLY FORCED VIBRATIONS OF ELECTRODED DOUBLY ROTATED QUARTZ PLATES BY STATE SPACE METHOD

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PROCEDURE OUTLINE

The purpose of this investigation is to develop an analytical method to study the vibration characteristics of piezoelectrically forced quartz plates. The procedure is schematically shown in Figure 1, and can be summarized as follows. The three dimensional governing equations of piezoelectricity, the constitutive equations and the strain-displacement relationships are used in deriving the final equations. For this purpose, a state vector consisting of stresses and displacements are chosen and the above equations are manipulated to obtain the projection of the derivative of the state vector with respect to the thickness coordinate on to the state vector itself. The solution to the state vector at any plane is then easily obtained in a closed form in terms of the state vector quantities at a reference plane. To simplify the analysis, simple thickness mode and plane strain approximations are used.



Figure 1

The governing equations of piezoelectricity consisting of the equations of motion and the charge equations of electrostatics are given by Equations (1) and (2). The quantities σ_{ij} , u_i and D_i are the components of stress, mechanical and electrical displacements. The constitutive equations are presented in Equations (3) and (4), where C_{ijkl} is the elastic stiffness, and ϵ_{kl} , e_{ijk} , E_i and S_{ij} are respectively the components of mechanical strain, piezoelectric strain constants, electric field and dielectric permitivity. The relationship between mechanical strain and displacement, and the relationship between electric field and electric potential are given in Equations (5) and (6) respectively.

EQUATIONS OF MOTION

$$\sigma_{ij,j} = \rho \, u_{i,tt} \tag{1}$$

CHARGE EQUATION OF ELECTROSTATICS

$$D_{i,i} = 0 \tag{2}$$

CONSTITUTIVE EQUATIONS

$$\sigma_{ij} = C_{ijkl} \epsilon_{kl} - e_{kij} E_k$$
(3)

$$D_{i} = e_{ijk} \epsilon_{jk} + S_{ij} E_{j}$$
⁽⁴⁾

$$\epsilon_{ij} = 0.5 (u_{i,i} + u_{i,j})$$
 (5)

$$\mathbf{E}_{\mathbf{i}} = -\phi_{\mathbf{i}} \tag{6}$$

Figure 2

The plane x1-x3 is taken to be the plane of the plate, and the x2-direction is considered as the thickness coordinate. The simple thickness mode approximation, in which the various quantities are just functions of the thickness coordinate, is used in the analysis. Also, the system is considered to be under plane strain conditions. Invoking the above assumptions, and using the contracted notation given by Equation (7), the surviving system of equations are presented in Equations (8) through (10). Differentiating the last of the equations (10), using the third of Equation (8) and integrating the resulting equation twice, the expression for ϕ is obtained (Equation 11), where A and B are constants of integration. A constant field does not produce any electric field, hence the constant B in Equation (11) is neglected. Substituting Equation (11) in Equation (10), the expressions for the non zero stress components are obtained, and are given in Equations 12 and 13.

CONTRACTED NOTATION

INVOKING SIMPLE THICKNESS MODE AND PLANE STRAIN ASSUMPTIONS

 $\sigma_{6,x2} = \rho \ u_{1,tt}$ $\sigma_{2,x2} = \rho \ u_{2,tt}$ $D_{2,x2} = 0$ (8)

$$\begin{bmatrix} \epsilon_{2} - u_{2, x2} \\ \epsilon_{6} - 1/2 u_{1, x2} \\ E_{2} - -\phi_{, x2} \end{bmatrix}$$
(9)

$$\sigma_{2} = 1/2 C_{26} u_{1,x2} + C_{22} u_{2,x2} + e_{22} \phi_{,x2}$$

$$\sigma_{6} = C_{66} u_{1,x2} + C_{62} u_{2,x2} + e_{26} \phi_{,x2}$$

$$D_{2} = 1/2 e_{26} u_{1,x2} + e_{22} u_{2,x2} - S_{22} \phi_{,x2}$$
(10)

 $\phi = \{ 1/2 \ e_{26} \ u_1 + e_{22} u_2 \} / S_{22} + Ax^2 + B$ (11)

$$\sigma_2 = a_{26} u_{1,x2} + a_{22} u_{2,x2} + e_{22}A$$
(12)

$$\sigma_6 = a_{66} u_{1,x2} + a_{62} u_{2,x2} + e_{26}A$$
(13)

Figure 3

A state vector $\{V\}$ defined by Equation (14) is chosen. The derivatives of the state vector with respect to x2 is obtained from Equations (8) through (13) and the resulting expressions are given in Equations (17) through (20). The elements of the matrices B1, B2 and B3 are made up of the material constants and derivatives with respect to x2 and time (t).

STATE VECTOR

$$\{V\} = [\{V_1\}^T \{V_2\}^T]^T$$

$$\{V_1\} = [u_1 \sigma_2]^T ; \{V_2\} = [\sigma_6 u_2]^T$$
(14)

$$\{V_1\}_{x2} = [B_1]_{v2} - A_{b_1}$$
 (15)

$$\{V_2\}_{x^2} = [B_2] \{V_1\} - A \{b_2\}$$
 (16)

$$\{V\}_{x2} = [B_3] \{V\} - A \{b_3\}$$
 (17)

B1 =
$$\begin{bmatrix} 1/a_{66} & -(a_{62}/a_{66}) & \partial/\partial x_2 \\ 0 & \rho & \partial^2/\partial t^2 \end{bmatrix} \qquad b1 = \begin{bmatrix} e_{26}/a_{66} \\ 0 \end{bmatrix}$$
(18)

$$B2 = \begin{bmatrix} \rho \ \partial^2 / \partial t^2 & 0 \\ -(a_{26}/a_{22}) \ \partial / \partial x_2 & 1/a_{22} \end{bmatrix} \qquad b2 = \begin{bmatrix} 0 \\ e_{22}/a_{22} \end{bmatrix}$$
(19)

$$a_{62} = C_{62} + e_{26}e_{22}/S_{22} ; a_{66} = 1/2 \{C_{66} + e_{26}^2/S_{22}\} \}$$

$$a_{26} = 1/2 \{C_{26} + e_{22}e_{26}/S_{22}\} ; a_{22} = C_{22} + e_{22}^2/S_{22}$$
(20)

Figure 4

A solution to the differential equation given in Equation (11) can be easily obtained and is given in Equation (21), where $\{VO\}$ is the state vector evaluated at $x^{2=0}$. The analyst has the flexibility of choosing any plane as the appropriate reference plane. The exponential term in Equation (21) can be expressed in an infinite series, and the powers of the matrix B3 can conveniently grouped as shown in Equation (23).

$$V = e^{B3 \times 2} (V0) + B3^{-1} A b3$$

(V0) = $\{V\}_{\chi 2=0}$ (21)

$$e^{B3x^2} \{V0\} = \left[I + B3 x^2 + (B3 x^2)^2/2! + (B3 x^2)^3/3! + \dots \right] \{V0\}$$
(22)

$$B3^{2} = \begin{bmatrix} P & 0 \\ 0 & Q \end{bmatrix} \qquad B3^{3} = \begin{bmatrix} 0 & B1Q \\ B2P & 0 \end{bmatrix}$$
(23)

$$B3^{4} = \begin{bmatrix} P^{2} & O \\ O & Q^{2} \end{bmatrix} \qquad B3^{5} = \begin{bmatrix} O & B1Q^{2} \\ B2P^{2} & O \end{bmatrix}$$

[Ρ]		[B1]	[B2]
[Q]	=	[B2]	[B1]

Figure 5

Using the expressions given in Equation (23), the infinite series expansion for the exponential term can be conveniently grouped as shown in Equation (24). The elements present in Equation (24) can be recognized as a convergent series. The resultant expression is given by Equation (25). Substituting this expression in Equation (21), the final equation for the state vector at any reference plane in terms of the state vector at a reference plane is obtained (Equation 26).

$$e^{B3x^{2}} (V0) = \left[I + \begin{bmatrix} 0 & B1 \\ B2 & 0 \end{bmatrix} x^{2} + \begin{bmatrix} P & 0 \\ 0 & Q \end{bmatrix} x^{2^{2}/2!} + \left[\begin{bmatrix} 0 & B1Q \\ B2P & 0 \end{bmatrix} x^{2^{3}/3!} + \begin{bmatrix} P^{2} & 0 \\ 0 & Q^{2} \end{bmatrix} x^{2^{4}/4!} + \left[\begin{bmatrix} 0 & B1Q^{2} \\ B2P^{2} & 0 \end{bmatrix} x^{2^{5}/5!} + \dots \right] (V0)$$
(24)

$$= \begin{bmatrix} \cosh (x2\sqrt{P}) & B1 \sqrt{Q} \sinh (x2\sqrt{Q}) \\ B2\sqrt{P} \sinh (x2\sqrt{P}) & \cosh (x2\sqrt{Q}) \end{bmatrix}$$
 (V0) (25)

$$= [R] \{V0\}$$
$$\{V\} = [R] \{V0\} + A [B3]^{-1} \{b3\}$$
(26)

Figure 6

Symbols and Abbreviations

- A, B Constants of integration
- a_{ij} Constant coefficients
- C_{ijkl} Elastic stiffness
- D_i Components of electric displacement
- e_{kij} Components of piezoelectric strain constant
- E_k Components of electric field
- S_{ij} Components of dielectric permittivity
- ui Components of mechanical displacement
- ϵ_{kl} Components of strain
- ρ Mass density
- σ_{ij} Stress components